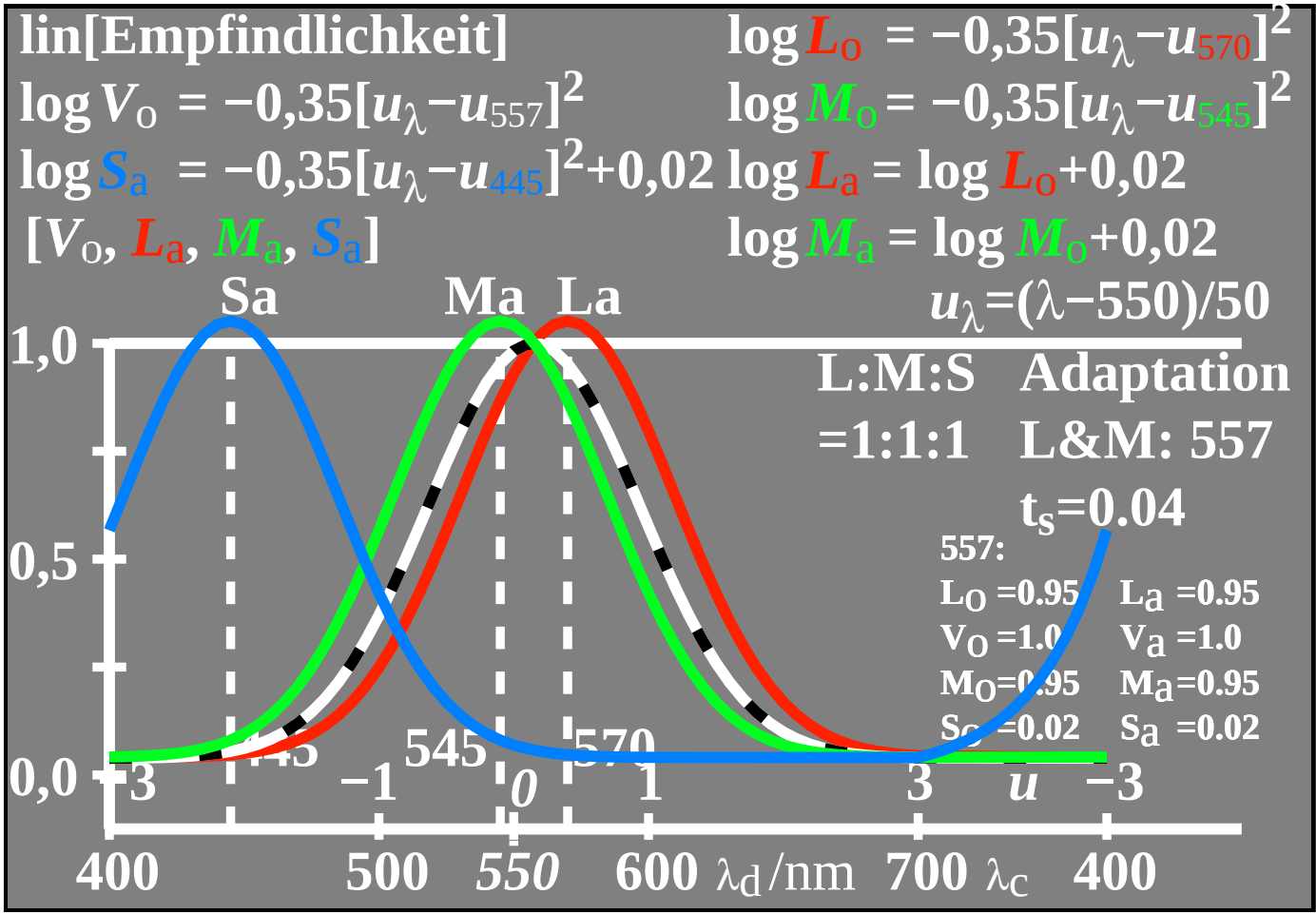
lin[Empfindlichkeit]
log V_O = −0,35[u_λ−u_557]²
log S_a = −0,35[u_λ−u_445]²+0,02
[V_O, L_a, M_a, S_a]
log L_O = −0,35[u_λ−u_570]²
log M_O = −0,35[u_λ−u_545]²
log L_a = log L_O+0,02
log M_a = log M_O+0,02
u_λ=(λ−550)/50
L:M:S =1:1:1
Adaptation L&M: 557
t_s=0.04
557:
L_O =0.95
L_a =0.95
V_O =1.0
V_a =1.0
M_O=0.95
M_a=0.95
S_O =0.02
S_a =0.02
Sa
Ma
La
1,0
0,5
0,0
445
545
570
3
−1
0
1
3
u
−3
400
500
550
600
λd/nm
700
λc
400

egx01−3a